

DOCKET NO: 285995US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
KOHEI KAWAMURA, ET AL. : EXAMINER: PARENDO, KEVIN A.  
SERIAL NO: 10/567,733 :  
FILED: FEBRUARY 10, 2006 : GROUP ART UNIT: 2823  
FOR: METHOD FOR FORMING FILM, :  
METHOD FOR MANUFACTURING  
SEMICONDUCTOR DEVICE,  
SEMICONDUCTOR DEVICE AND  
SUBSTRATE TREATMENT SYSTEM

AMENDMENT UNDER 37 C.F.R. § 1.111

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated April 8, 2009, please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 4 of this paper.

**Amendments to the Drawings** begin on page 10 of this paper and include an attached replacement sheet.

**Remarks/Arguments** begin on page 11 of this paper.